

**AMENDMENTS TO THE ABSTRACT:**

Please amend the Abstract as follows:

**ABSTRACT OF THE DISCLOSURE**

A method of manufacturing a lamination-type piezoelectric element (~~1~~) ~~comprises:~~includes forming a ceramic laminated body (~~10~~) in which ceramic layers and inner electrode layers (~~12~~) are alternately laminated on each other; ~~and a.~~ A pair of outer electrodes (~~18~~) are respectively joined to a pair of joining faces (~~15~~) formed on an outer circumferential face of the ceramic laminated body (~~10~~). A belt-shaped outer circumferential groove portion (~~120~~) coming into contact with an outer circumferential end portion (~~127~~) of at least some part of the inner electrode layers (~~12~~) is formed on the outer circumferential face of the ceramic laminated body (~~10~~). This outer circumferential groove portion (~~120~~) has at least one dent portion (~~121~~) protruding from the adjoining portion. The outer circumferential groove portion (~~120~~) has at least one of an insulating portion (~~181~~) made of insulating material and a conductive portion (~~183~~) made of conductive material.